

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang                      Art Unit : 2814  
Serial No. : 09/362,808                      Examiner : Shrinivas H. Rao  
Filed : July 28, 1999                      Conf. No. : 7320  
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

**MAIL STOP RCE**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

The references included in this information disclosure statement were cited in U.S. Application Serial No. 11/275,021, which is directed to subject matter similar to that of the present application.

This filing is being made with the filing of a Request for Continued Examination. No fee is required.

Respectfully submitted,

Date: 10/31/07

  
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